



AFRL-RZ-WP-TP-2012-0098

GROWTH OPTIMIZATION OF YBa_2NbO_6 BUFFER LAYERS (POSTPRINT)

N.A. Yust, T.J. Haugan, J.C. Tolliver, and P.N. Barnes

**Mechanical Energy Conversion Branch
Energy/Power/Thermal Division**

S. Sathiraju

NRC

R.N. Nekkanti

UES, Inc.

I. Maartense

Materials and Manufacturing Directorate

FEBRUARY 2012

Approved for public release; distribution unlimited.

See additional restrictions described on inside pages

STINFO COPY

© 2004 Materials Research Society

**AIR FORCE RESEARCH LABORATORY
PROPULSION DIRECTORATE
WRIGHT-PATTERSON AIR FORCE BASE, OH 45433-7251
AIR FORCE MATERIEL COMMAND
UNITED STATES AIR FORCE**

REPORT DOCUMENTATION PAGE				Form Approved OMB No. 0704-0188	
The public reporting burden for this collection of information is estimated to average 1 hour per response, including the time for reviewing instructions, searching existing data sources, gathering and maintaining the data needed, and completing and reviewing the collection of information. Send comments regarding this burden estimate or any other aspect of this collection of information, including suggestions for reducing this burden, to Department of Defense, Washington Headquarters Services, Directorate for Information Operations and Reports (0704-0188), 1215 Jefferson Davis Highway, Suite 1204, Arlington, VA 22202-4302. Respondents should be aware that notwithstanding any other provision of law, no person shall be subject to any penalty for failing to comply with a collection of information if it does not display a currently valid OMB control number. PLEASE DO NOT RETURN YOUR FORM TO THE ABOVE ADDRESS.					
1. REPORT DATE (DD-MM-YY) February 2012		2. REPORT TYPE Conference Paper Postprint		3. DATES COVERED (From - To) 01 January 2002 – 01 January 2004	
4. TITLE AND SUBTITLE GROWTH OPTIMIZATION OF YBa ₂ NbO ₆ BUFFER LAYERS (POSTPRINT)				5a. CONTRACT NUMBER In-house	
				5b. GRANT NUMBER	
				5c. PROGRAM ELEMENT NUMBER 62203F	
6. AUTHOR(S) N.A. Yust, T.J. Haugan, J.C. Tolliver, and P.N. Barnes (AFRL/RZPG) S. Sathiraju (NRC) R.N. Nekkanti (UES, Inc.) Iman Maartense (AFRL/RX)				5d. PROJECT NUMBER 3145	
				5e. TASK NUMBER 32	
				5f. WORK UNIT NUMBER 314532Z9	
7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES) Mechanical Energy Conversion Branch (AFRL/RZPG) Energy/Power/Thermal Division Air Force Research Laboratory, Propulsion Directorate Wright-Patterson Air Force Base, OH 45433-7251 Air Force Materiel Command, United States Air Force ----- NRC				8. PERFORMING ORGANIZATION REPORT NUMBER AFRL-RZ-WP-TP-2012-0098	
9. SPONSORING/MONITORING AGENCY NAME(S) AND ADDRESS(ES) Air Force Research Laboratory Propulsion Directorate Wright-Patterson Air Force Base, OH 45433-7251 Air Force Materiel Command United States Air Force				10. SPONSORING/MONITORING AGENCY ACRONYM(S) AFRL/RZPG	
				11. SPONSORING/MONITORING AGENCY REPORT NUMBER(S) AFRL-RZ-WP-TP-2012-0098	
12. DISTRIBUTION/AVAILABILITY STATEMENT Approved for public release; distribution unlimited.					
13. SUPPLEMENTARY NOTES Conference paper published in the proceedings of the <i>Materials Research Society Symposium</i> , Vol. EXS-3, 2004. © 2004 Materials Research Society. The U.S. Government is joint author of the work and has the right to use, modify, reproduce, release, perform, display, or disclose the work. Work on this effort was completed in 2004. This paper has color content. PA Case Number: ASC-03-3094; Clearance Date: 06 Dec 2004.					
14. ABSTRACT The growth optimization of YBa ₂ NbO ₆ (YBNO) buffer layers on LaAlO ₃ (100), MgO (100) single crystals, and IBAD MgO buffered Inconel substrates has been investigated. X-ray diffraction confirms the epitaxial growth of highly <i>h00</i> oriented YBNO thin films on single crystal substrates and IBAD MgO buffered Inconel substrates. The best average surface roughness of the YBNO films deposited on buffered substrates is 2 nm. The critical temperature (<i>T_c</i>) of YBa ₂ Cu ₃ O _{7-x} (Y-123) thin films deposited on these YBNO buffer layers ranges from 80 to 87 K. The deposition of YBNO may be further optimized and the IBAD MgO layers were only of sufficient quality to test for compatibility and epitaxial growth of the new buffer. Hence, the results presented here are preliminary in nature and can be improved upon.					
15. SUBJECT TERMS diffraction, crystal, buffered, inconel, epitaxial, films, substrates, layers, growth, investigated, sufficient, preliminary, critical					
16. SECURITY CLASSIFICATION OF:			17. LIMITATION OF ABSTRACT: SAR	18. NUMBER OF PAGES 10	19a. NAME OF RESPONSIBLE PERSON (Monitor) Timothy J. Haugan 19b. TELEPHONE NUMBER (Include Area Code) N/A
a. REPORT Unclassified	b. ABSTRACT Unclassified	c. THIS PAGE Unclassified			

Growth Optimization of YBa_2NbO_6 Buffer Layers

S. Sathiraju¹, N.A. Yust, R.N. Nekkanti², I. Maartense³, A.L. Campbell³, T.L. Peterson³, T.J. Haugan, J.C. Tolliver, P.N. Barnes

¹NRC, ²UES Inc., ³AFRL/MLP
Air Force Research Laboratory, PRPG,
2645 Fifth St., Bldg. 450, Wright-Patterson AFB, OH 45433

Q.X. Jia, P.N. Arendt
Superconductor Technology Center, Los Alamos National Laboratory, NM 87545

ABSTRACT

The growth optimization of YBa_2NbO_6 (YBNO) buffer layers on LaAlO_3 (100), MgO (100) single crystals, and IBAD MgO buffered Inconel substrates has been investigated. X-ray diffraction confirms the epitaxial growth of highly $h00$ oriented YBNO thin films on single crystal substrates and IBAD MgO buffered Inconel substrates. The best average surface roughness of the YBNO films deposited on buffered substrates is 2 nm. The critical temperature (T_c) of $\text{YBa}_2\text{Cu}_3\text{O}_{7-x}$ (Y-123) thin films deposited on these YBNO buffer layers ranges from 80 to 87 K. The deposition of YBNO may be further optimized and the IBAD MgO layers were only of sufficient quality to test for compatibility and epitaxial growth of the new buffer. Hence, the results presented here are preliminary in nature and can be improved upon.

INTRODUCTION

The quality of superconducting films epitaxially grown highly depends on the substrate choice. It is well known that SrTiO_3 (100), LaAlO_3 (100), YSZ (100) and MgO (100) are suitable single crystal substrates for producing high quality superconducting thin films, especially $\text{YBa}_2\text{Cu}_3\text{O}_{7-x}$ (Y123). However, it has been reported that for 123 films deposited on MgO single crystal, an interlayer of barium salt is formed at the interface if the processing temperature is above 700 °C [1]. Also, another problem reported with the films grown on MgO is the presence of 45° in-plane rotated grains which degrades the crystalline quality of the deposited $\text{RBa}_2\text{Cu}_3\text{O}_x$ (where R = Y, rare earths) [2,3]. A possible solution is to use a suitable buffer layer on the MgO substrate for the growth of the subsequent Y123 film. The same concept can be extended to coated conductor applications. YBa_2NbO_6 (YBNO) has a cubic perovskite structure ($a \sim 8.4$ Å) and has moderate dielectric properties [4]. In this paper we report the growth of YBa_2NbO_6 compound as a new dielectric buffer layer on MgO (100) and LaAlO_3 (100) single crystal, and IBAD MgO buffered Inconel substrates for the subsequent deposition of Y123 thin films.

EXPERIMENTAL

YBa_2NbO_6 target has been prepared with 4N purity Y_2O_3 , BaCO_3 and Nb_2O_5 powders by the standard solid-state synthesis method. LPX 304i Kr F excimer Laser with 248nm wavelength

was used to deposit YBNO films and subsequent Y-123 thin film deposition on various substrates. Substrate block temperatures are varied between room temperature to 850 °C. Other parameters such as O₂ (250 mTorr) pressure, Substrate Target distance (7cm), laser pulse energy 3J/cm² and pulse frequency (6Hz) are kept constant during the YBNO deposition. The texture of IBAD MgO buffered Inconel substrates obtained from LANL is 4-6°. Films were characterized by x-ray diffraction (XRD), atomic force microscopy (AFM), and ac susceptibility measurements.

RESULTS AND DISCUSSION

XRD results confirm that YBNO films deposited on single crystal substrates are epitaxial and transparent (Figure 1). YBNO films deposited on IBAD MgO buffered Inconel are highly *h00* oriented. Epitaxial YBNO films were grown between 800-850° C on single crystal substrates and IBAD MgO buffered Inconel metal substrates. Films deposited at room temperature are amorphous. The surface morphology of the YBNO films reveals out growths even though the average surface roughness is only 2-4 nm (Figure 2). The average surface roughness *Ra* of YBNO films determined from AFM studies is listed in Table 1. Highly c-axis oriented Y-123 film was deposited on CeO₂/YBNO/IBADMgO/Inconel. Critical temperatures (*T_c*) determined from AC susceptibility measurements vary about 80-89 K on different substrates (Table 2). The broadening of the χ'' or χ' curves suggest that there is a weakly coupled grain structure (Figure 3). The deposition of YBNO may be further optimized as the IBAD MgO samples were only of sufficient quality to test for compatibility and epitaxial growth of the new buffer. Hence, the results presented here are preliminary in nature and can be improved upon in future work.

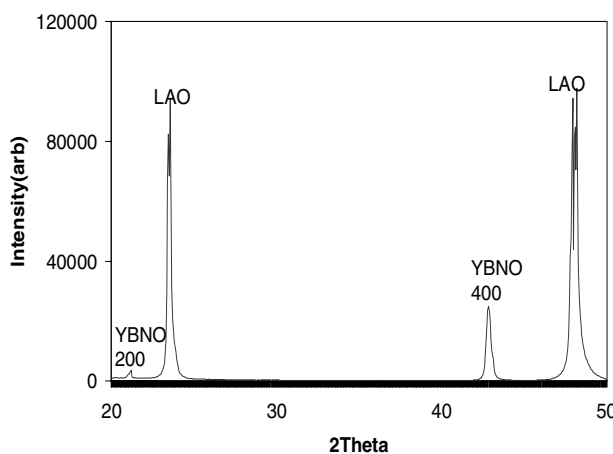


Figure 1

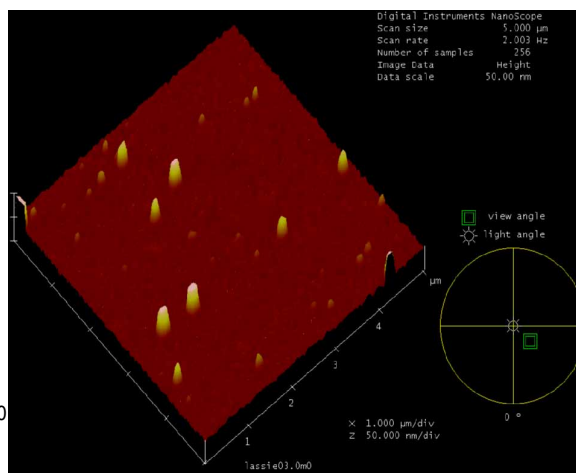


Figure 2

Figure 1. XRD pattern of *epitaxial* YBNO film on LaAlO₃ (LAO)

Figure 2. AFM micrograph of YBNO film deposited on IBAD MgO substrate

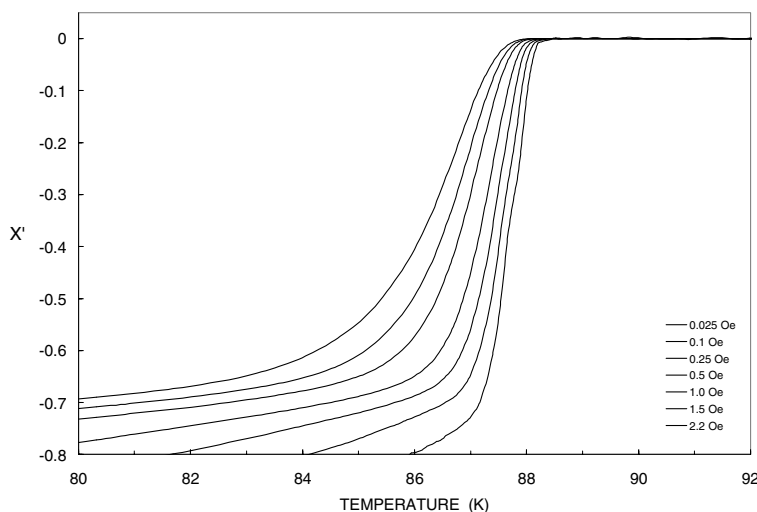


Figure 3. AC susceptibility data of Y-123 film deposited on CeO₂/YBNO/IBAD MgO/Inconel

Table 2. YBNO Surface roughness data from AFM analysis

Substrate	YBNO RMS roughness (nm)	T _c of Y123 film (from ac susceptibility)
LaAlO ₃ (100)	3-7	82
MgO (100)	2-6	84
IBAD MgO	2-4	86
Inconel	5- 40	80

CONCLUSIONS

Epitaxial YBNO films were grown on single crystal as well as IBAD MgO buffered metal substrates. Initial results of Y123 thin films deposited on these buffer layers are promising for coated conductor applications. Further optimization of the buffer layer is in progress.

ACKNOWLEDGEMENTS

Sathiraju acknowledges National Research Council, National Academy of Sciences, Air Force Office of Scientific Research, and the Propulsion Directorate of Air Force Research Laboratory for SRA fellowship and research support.

REFERENCES

1. Koinuma et al., *Jpn. J. Appl. Phys.* **27**, L1216 (1988)
2. Mukadia M et al *Supercond. Sci. Tech.* **12**, 890 (1999)
3. Yoshitake T et al *IEEE Trans Appl. Supercon.* **9**, 3058 (1999)
4. Babu T.G. N and Koshy J. *Solid state Chem.* **126**, 202 (1996)